

***IN THE UNITED STATES PATENT AND TRADEMARK OFFICE***

Applicant: Takeshi HIKATA

Title: METHOD OF PRODUCING  
CARBON NANOSTRUCTURE

Appl. No.: 10/591,740

International 5/19/2005

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Examiner: Roberts P. Culbert

Art Unit: 1792

Confirmation 3133

Number:

**ISSUE FEE TRANSMITTAL**

Mail Stop Issue Fee  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Enclosed herewith please find Issue Fee Transmittal Form PTOL-85(B).

Fees in the amount of \$1,810.00 for payment of the Issue Fee and the Publication Fee are being paid by credit card via EFS-Web.

The Commissioner is hereby authorized to charge any additional fees which may be required regarding this application under 37 C.F.R. §§ 1.16-1.17, or credit any overpayment, to Deposit Account No. 19-0741.

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Respectfully submitted,

By

Date

12-17-09

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